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## \*BIBDATASHEET\*

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CONFIRMATION NO. 8569

SERIAL NUMBER 10/670,249	FILING DATE 09/26/2003 RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. 242758US-620-39-2- S DIV
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*

This application is a DIV of 09/892,487 06/28/2001 PAT 6,642,568 *MJ*

## \*\* FOREIGN APPLICATIONS \*\*\*\*

JAPAN 2000-197801 06/30/2000 *WJ*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 12/20/2003

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	13	14	1
Verified and Acknowledged	<i>ble</i>	Examiner's Signature	Initials		

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## TITLE

Method of manufacturing semiconductor device using sti technique

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )

FILING FEE FEES: Authority has been given in Paper